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Katherine Klandas
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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Gilyong Chung
Chin Che Tin
John R. Williams
Kyle McDonald
Massimiliano Di Ventra
Robert A. Weller
Sokrates T. Pantelides
Leonard C. Feldman

Group Art Unit: 2812

Examiner: Unknown

Atty. Dkt. No.: 2026.000900/RCF

Serial No.: 09/818,913¹⁹³

Filed: 03/26/2001

For: INCLUSION OF NITROGEN AT THE
SILICON DIOXIDE-SILICON CARBIDE
INTERFACE FOR PASSIVATION OF
INTERFACE DEFECTS

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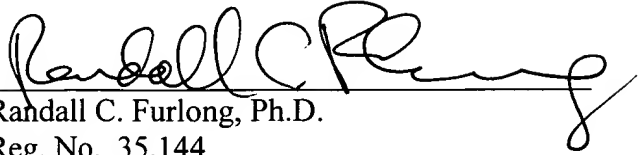
Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Please direct all future communications regarding this application as follows:

Randall C. Furlong, Ph.D.
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Respectfully submitted,

A handwritten signature in black ink, appearing to read "Randall C. Furlong", written over a horizontal line.

Randall C. Furlong, Ph.D.
Reg. No. 35,144

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Date: September 19, 2001